

## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kei HIRUMA et al.

Application No.: 10/626,565

Filed: July 25, 2003

Docket No.: 116695

For:

DROPLET DISCHARGE METHOD, DROPLET DISCHARGE APPARATUS,

MANUFACTURING METHOD FOR LIQUID CRYSTAL DEVICE, LIQUID CRYSTAL

DEVICE, AND ELECTRONIC APPARATUS

## **PRELIMINARY AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Remarks.